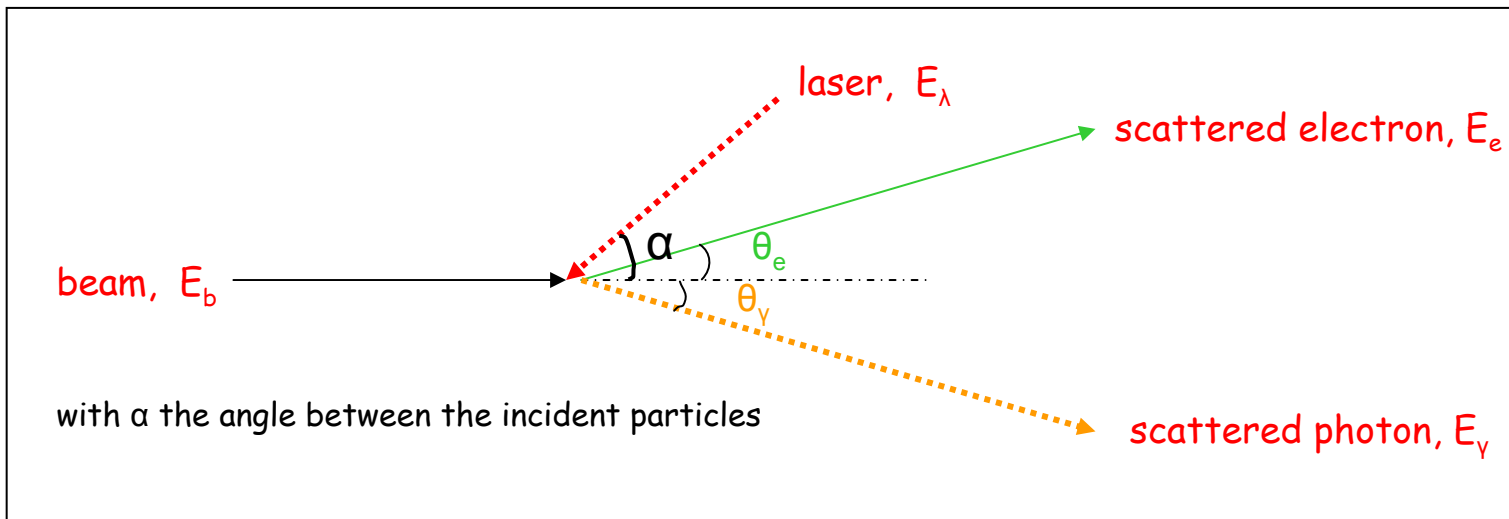


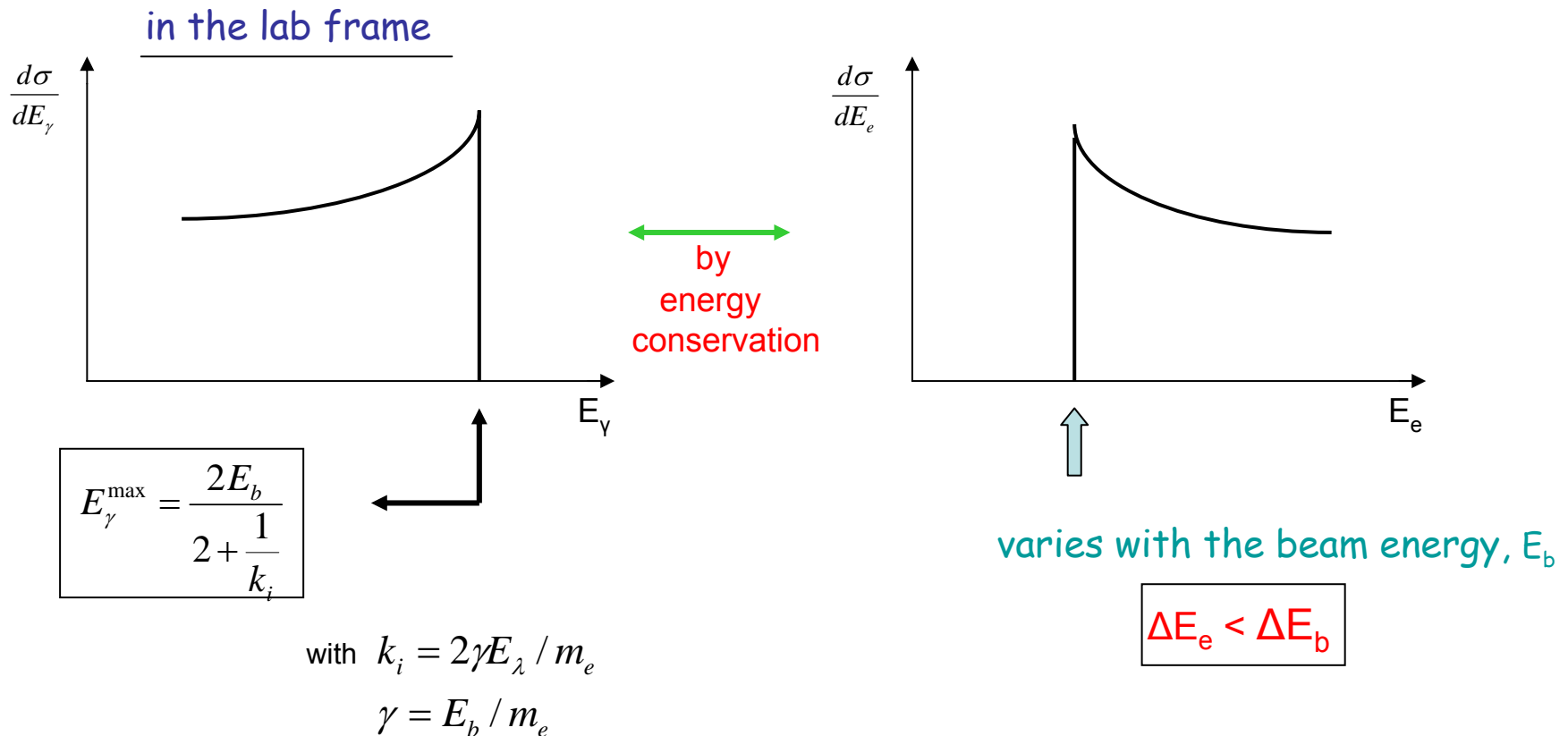
# Precise ILC Beam Energy Measurement using Compton backscattering

Process :



## Basic properties (kinematics) of scattered photon resp. electron:

- *sharp edge* in the energy distribution
- both particles are *strongly forward collimated*
- the *position of the edge is not dependent on the initial polarization state*



The *energy of the edge electrons* depends

- on the primary *beam energy* ( $E_b = 250 \text{ GeV}$  (45 ... 500 GeV))
- the laser wavelength resp. the *laser energy*,  $E_L$  ( $\sim \text{eV}$ )
- the *angle*  $\alpha$ , the angle between the incoming particles  
(which should be chosen to be very small)

These quantities determine whether the edge electrons (photons) have a large or small energy: once  $E_L$  and  $\alpha$  are fixed  $\rightarrow$  access to the beam energy  $E_b$

Our basic requirement of  $\Delta E_b/E_b = 10^{-4}$  means to note an absolute shift of the beam energy of  $\Delta E_b = 25$  (50) MeV at  $E_b = 250$  (500) GeV

!

Example:  $E_b = 250 \text{ GeV}$ ,  $\alpha = 0.$ ,  $\text{CO}_2$  laser ( $E_L = 0.117 \text{ eV}$ )

$\rightarrow E_e(\text{edge}) = 173 \text{ GeV}$  and  $\Delta E_e = 11.9 \text{ MeV}$  for  $\Delta E_b = 25 \text{ MeV}$

Nd:YAG (green,  $E_L = 2.33 \text{ eV}$ )

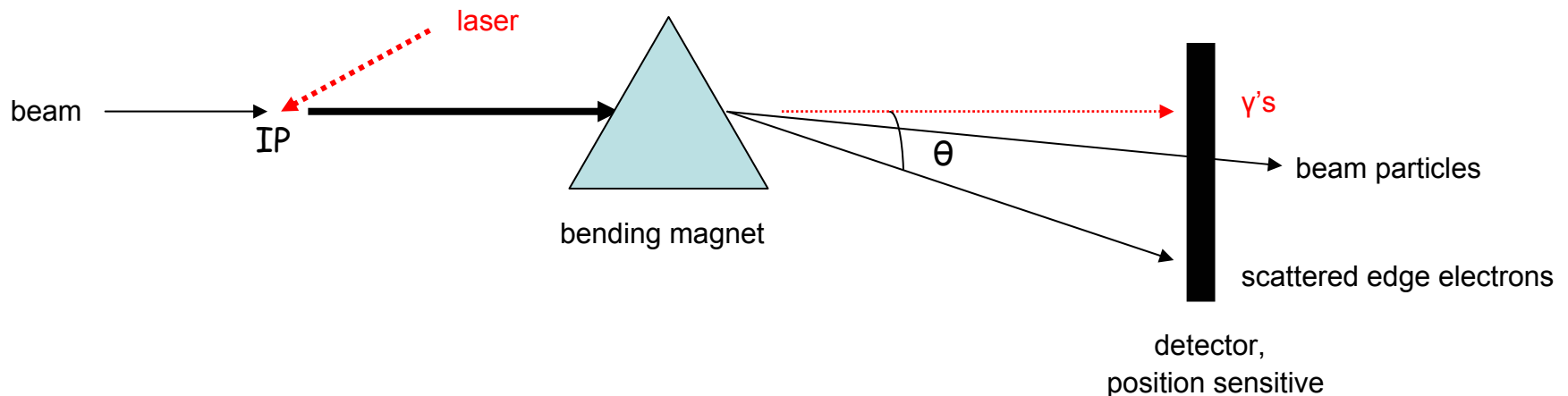
$\rightarrow E_e(\text{edge}) = 25 \text{ GeV}$  and  $\Delta E_e = 0.254 \text{ MeV}$



lasers with large wavelength are preferred

## Sketch of possible experiment

- The beam electrons interact with the laser photons at very small angle  $\alpha$ , so that downstream of the IP **untouched beam particles** (most of them), **scattered electrons** and **photons** exist. All these particles are overlaid and strongly collimated in the forward direction.
- By a **dipole magnet** these particles are divided into through-going photons, less deflected beam particles and scattered electrons with some larger bending angles.
- The **electrons** with the **largest bending angle** are the **edge electrons** and their position in the detector should be carefully measured.



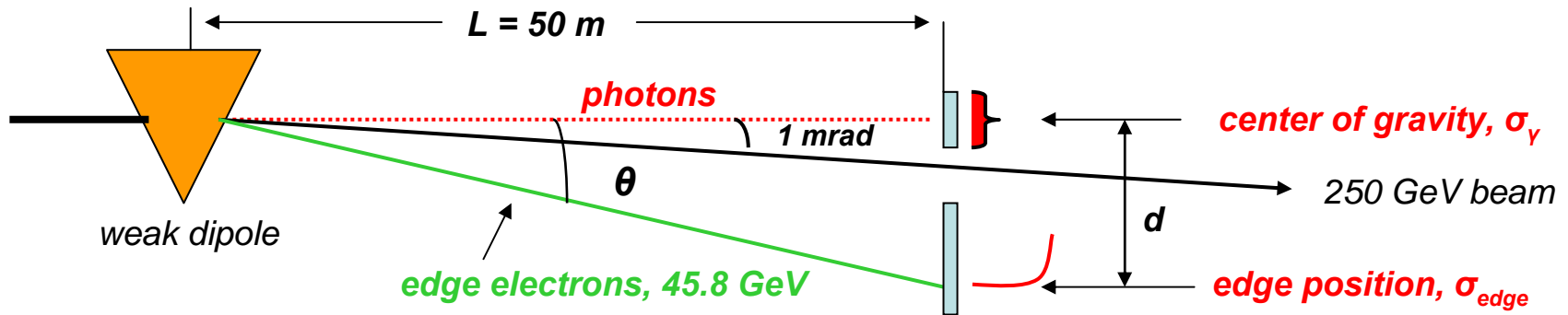
Having precise information on the bending angle  $\theta$  of the edge electrons and the B-field integral, the beam energy (for each bunch ?) can be determined -- *how well ?*

Example:

Aim:

$$\Delta E_b / E_b = 10^{-4}$$

infrared Nd:YAG laser ( $E_L = 1.165 \text{ eV}$ )



in this example,  $\theta$  is 5.46 mrad  
resulting to  $d = 27.3 \text{ cm}$

Note, if  $E_b$  changes by 25 MeV,

$$\text{and } \Delta L = 0.1 \text{ mm, } \Delta \int B dl / \int B dl = 10^{-5}$$

one needs a precision for the distance  $d$  of



$$\Delta d = 5 \mu\text{m} !$$

to recognize a 25 MeV shift  
of beam energy

Using a CO<sub>2</sub> laser with  $E_\lambda = 0.117$  eV and the same set-up

→ energy of the edge electrons **172.6 GeV**  
with an offset in the detector  $d = \underline{7.2}$  cm

→  $\Delta d = 7-8 \mu\text{m}$

$$\frac{\Delta E_b}{E_b} = \sqrt{\left(\frac{\Delta B}{B}\right)^2 + \left(\frac{\Delta \theta}{\theta}\right)^2}$$

$$\frac{\Delta \theta}{\theta} = \sqrt{\left(\frac{\Delta L}{L}\right)^2 + \left(\frac{\Delta d}{d}\right)^2}$$

independent on laser

For fixed B-field and distance L (magnet → detector)  
the relative error on d

→  $\Delta d/d$  (CO<sub>2</sub>) = 5.4 ·  $\Delta d/d$  (Nd:YAG)

due to the small value of d in the CO<sub>2</sub> case



non-trivial task to select the best suitable laser  
in conjunction with many other parameters  
(B-field, L, detector, ...)

## GEANT SIMULATIONS

included

- beam sizes of the electron bunches ( $\sigma_x = 20 \mu\text{m}$ ,  $\sigma_y = 2 \mu\text{m}$ ,  $\sigma_z = 300 \mu\text{m}$ )
- beam dispersion of  $5 \mu\text{rad}$  in  $x$  and  $y$
- beam energy spread of  $0.15 \%$  of the nominal energy of  $250 \text{ GeV}$
- # of electrons/bunch =  $2 \cdot 10^{10}$ , unpolarized
  
- bending magnet of  $3 \text{ m}$  length with  $B$ -field of  $2.75 \text{ kG}$ ; fringe field included, bending in vertical ( $y$ ) direction;  $\leftrightarrow$  flat horizontal beam
- synchrotron radiation ON
- distance between magnet and detector  $L = 50 \text{ m}$
- scattering angle in the initial state  $\alpha = 8 \text{ mrad}$ ; vertical beam crossing
  
- infrared Nd:YAG laser ( $E_\lambda = 1.165 \text{ eV}$ ) resp.  $\text{CO}_2$  laser ( $E_\lambda = 0.117 \text{ eV}$ ) used
- laser dispersion of  $5 \text{ mrad}$  in  $x$  and  $y$ , i.e. the laser is focused to the IP
- Nd:YAG laser: spot size at IP of  $45 \mu\text{m}$ , power/pulse =  $2 \text{ mJ}$   
and a pulse duration of  $10 \text{ psec}$  (with a spacing of  $337 \text{ nsec}$ )
- $\text{CO}_2$  laser: spot size at IP of  $100 \mu\text{m}$ , power/pulse =  $1 \text{ mJ}$   
and a pulse duration of  $10 \text{ psec}$  (with a spacing of  $337 \text{ nsec}$ )  
→ laser monochromaticity of  $3 \cdot 10^{-3}$  resp.  $3 \cdot 10^{-2}$  for YAG and  $\text{CO}_2$  laser
  
- perfect overlap of both beams

## Gaussian smearing

- IP position according to beam sizes in x and y
- direction of beam according to beam dispersion
- energy of beam according to beam energy spread
- direction of laser according to laser dispersion
- angle between the incoming beam and laser  
according to beam and laser directions
- laser energy according to laser duration ( $dw/w \sim \lambda/(c \cdot t)$ )
- B-field according to its error

Synchrotron radiation (a stochastic process) in GEANT was switched  
on all the time

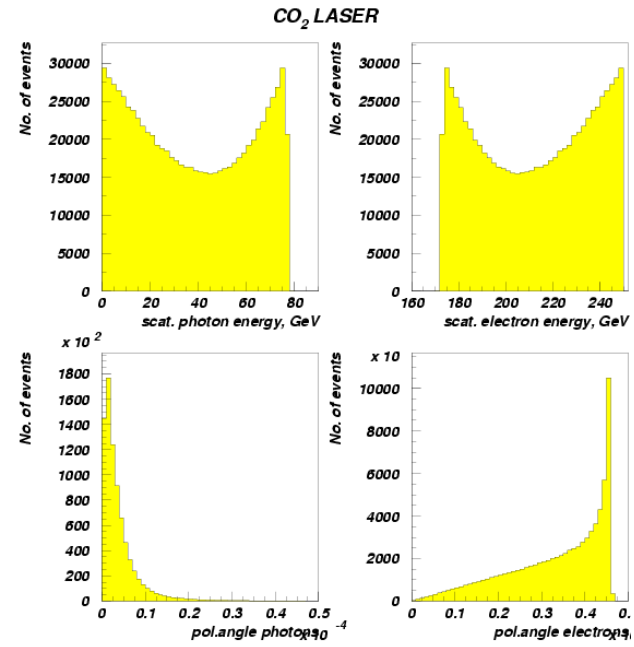
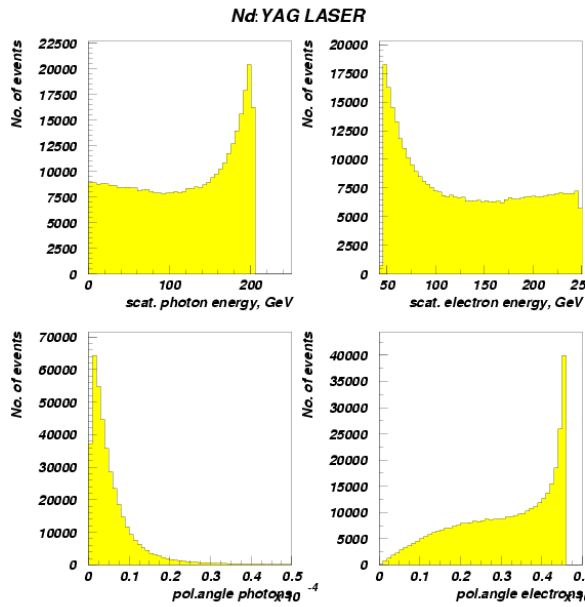
In simulation studies, individual Gaussian smearing can be ON or OFF  
→ most important effects can be realized and accounted for

So far, non-linear effects which occur during the beam-laser interaction  
and which disturb the scattered electron edge behavior NOT taken into account  
→ expected to be small or negligible due to small laser power ?

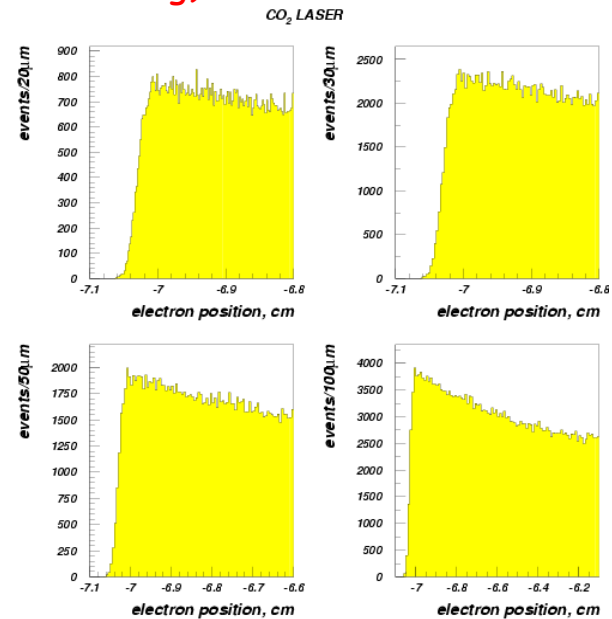
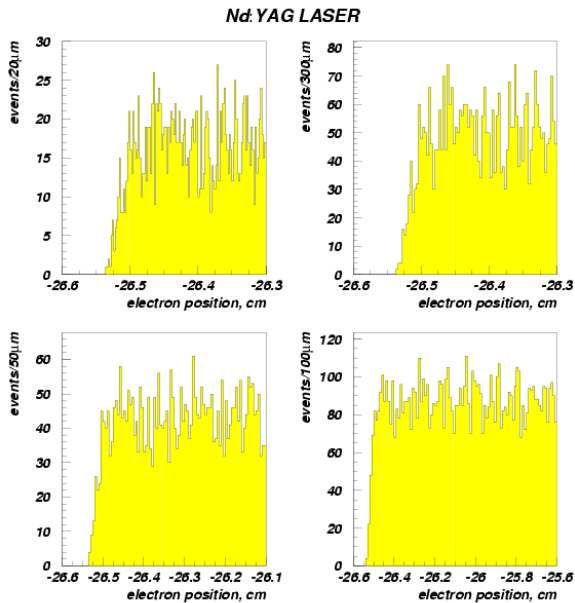
NO detector effects



# Characteristics of scattered particles (complete smearing):

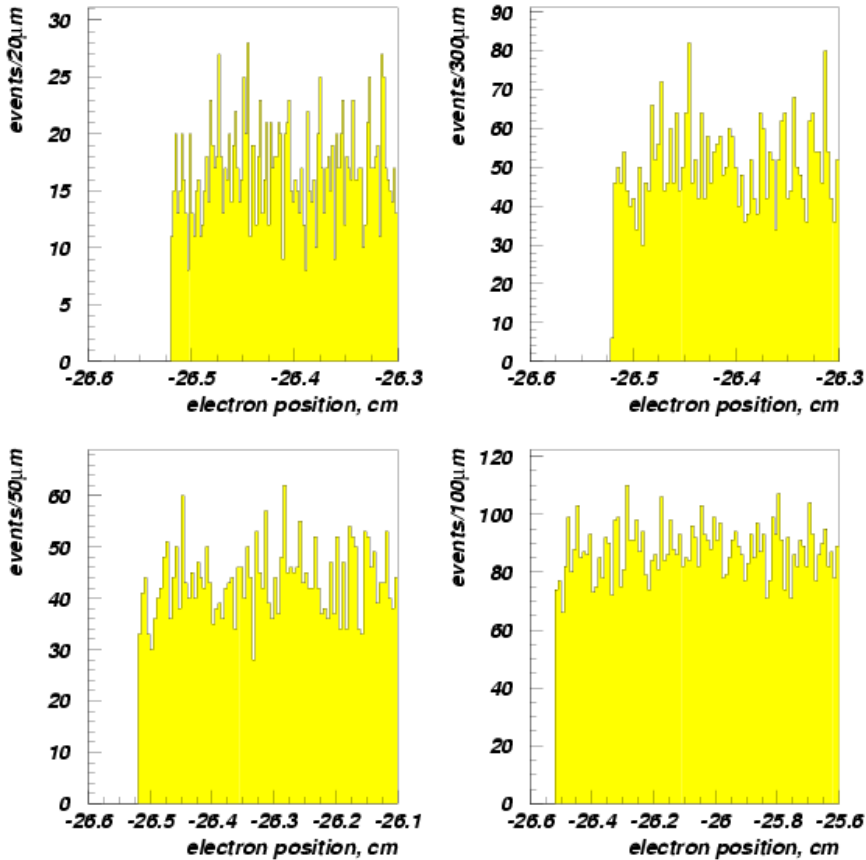


# Position of the edge electrons in the detector (complete smearing)

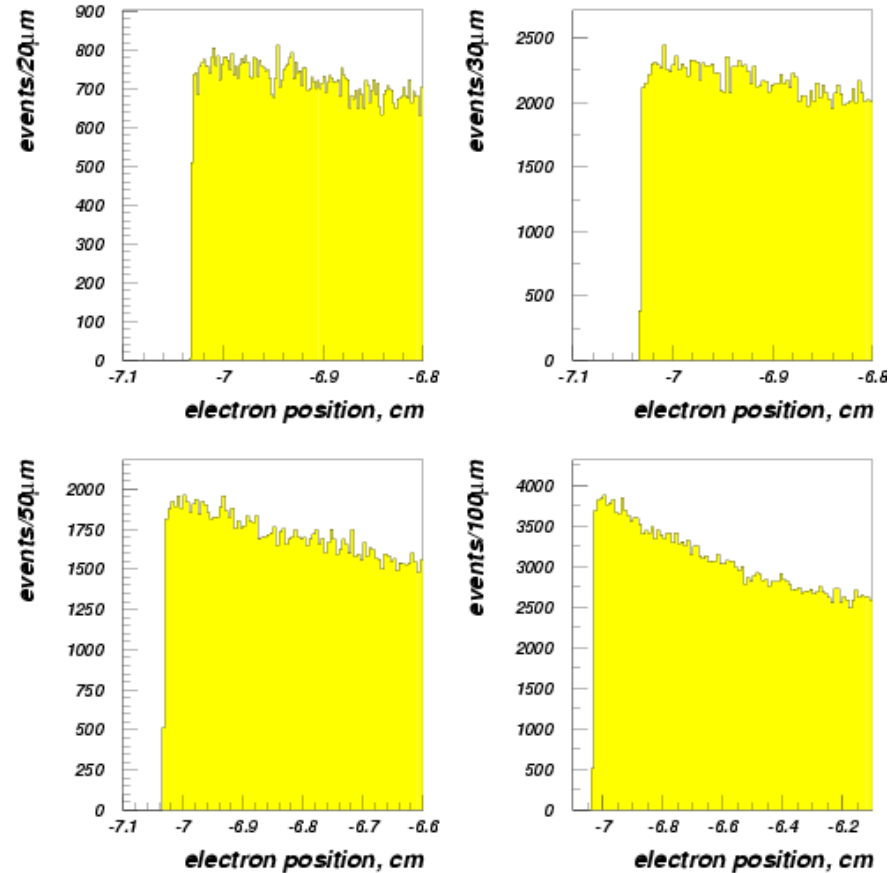


## Position of the edge electrons in the detector (NO smearing, except SR):

Nd:YAG LASER



CO<sub>2</sub> LASER



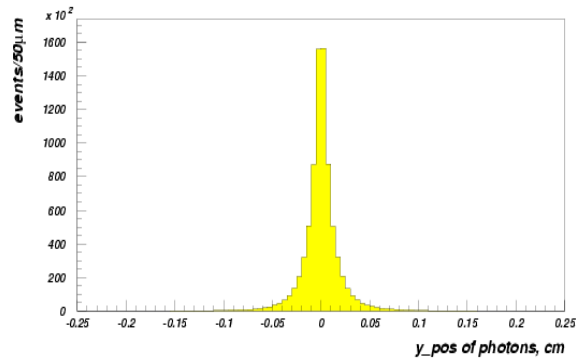
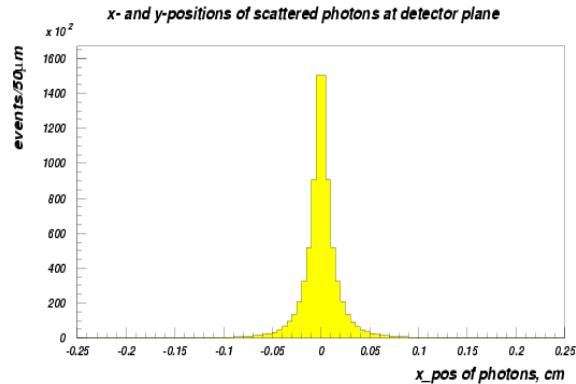
From simulations with several smearing effects ON or OFF

→ beam and laser energy uncertainties are most important  
for the electron edge behavior

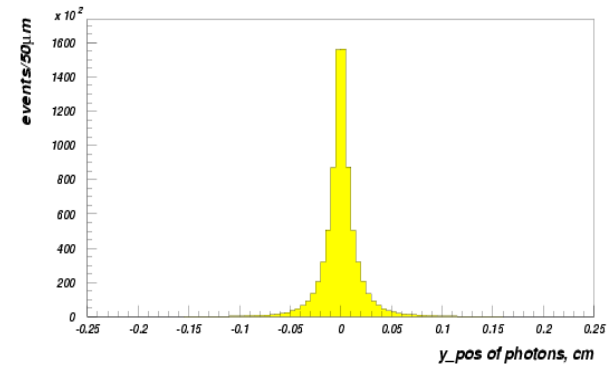
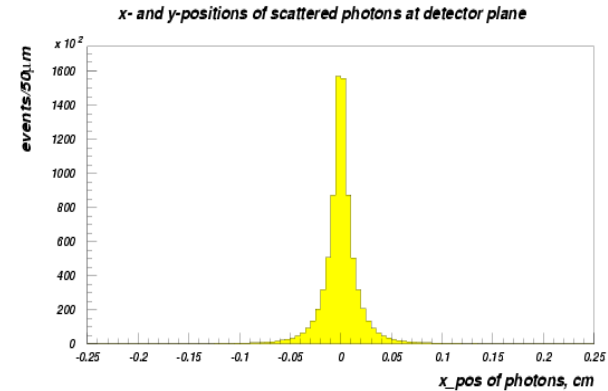
for e- beam: both beam energy uncertainties contribute with about equal weights  
e+ beam: the uncertainty of the laser energy is dominant and governs the edge

# Detector positions of the scattered photons (CO<sub>2</sub>):

complete smearing



no smearing



no difference between the two cases visible

→ position of scattered photons in detector insensitive to input parameters

(good news)

- Clear, the  $CO_2$  laser provides more electrons close to the edge than the Nd:YAG laser due to larger cross section and somewhat better kinematics in the edge region.
- With assumed laser and electron beam parameters and scattering angle  $\alpha$ 
  - # of Compton scatters  $4 \cdot 10^5$  for the Nd:YAG laser, while  $8 \cdot 10^5$  for the  $CO_2$  laser
  - negligible event rate w.r.t. the total bunch intensity → method is nondestructive, and the large ILC bunch spacing should allow for single bunch measurements
- Optimization of the experiment not trivial, in particular the selection of the laser, to be sensitive on a tiny beam energy jump of 25 MeV or less.
- Including further information e.g. from the scattered photons has to be considered.
- Do we need some further beam line elements in the set-up ?
- Whatever we do, the emittance of the beam should not be diluted; if however an emittance grow cannot be avoided → think about on a dedicated measuring scheme.

## Summary (preliminary)

- **Laser:** ongoing laser activities

- Nd:YAG laser (infrared)

- e.g. at TTF Nd:YLF laser ( $\lambda = 1.047 \mu\text{m}$ )  $\rightarrow$  3 MHz repetition rate and peak/power of 140  $\mu\text{J}$   
 $\rightarrow$  a factor  $\sim 10$  off our needs

- $\text{CO}_2$  laser

- polarized positron source collaboration (see e.g. NIM A 500 (2003) 232) proposed a  $\text{CO}_2$  laser with 121 pulses with 2.8 nsec spacing and a pulse power of 250 mJ

- resp. recent Snowmass proposal (physics/0509016)

- $\rightarrow$   $3.6 \cdot 10^4$  pulses with 3 psec rms bunch duration and power/pulse of 2.1 mJ

- $\rightarrow$   $\text{CO}_2$  laser advantageous (needs more studies), but does not exist

- $\rightarrow$  infrared Nd:YAG (Nd:YLF) promising, power increase needed no showstopper

- **Magnet:**

- a field error of  $2 \cdot 10^{-5}$  today achievable  $\rightarrow$  very close to our needs  $(1-1.5) \cdot 10^{-5}$

- vertical bending preferred since  $\sigma_y \ll \sigma_x$  (flat beam), also background smaller (?),

- what about emittance in y-direction ?, check horizontal

- **Detector** for scattered photons, electrons

- bending !

- measure the distance  $d$  with a precision of 5-8  $\mu\text{m}$ , bunch by bunch (?)  $\rightarrow$  CHALLENGING

- === silicon strip detector ===

- **set-up** also usable for (crude) beam profile determination, using the photon spatial distributions in the detector

## Further items to be studied

- decision on the best suitable laser and a laser line design
- detector has to be designed and implemented into simulation studies
- optimization of parameters of the set-up
- detailed GEANT simulation
- background ?
- account for experiences and results from low-energy experiments
- partners are very welcome
- . . .

With all that, including further ideas, a conceptual design report in ~ 1 year

*With some optimism and further suggestions it seems possible*

*to achieve  $\Delta E_b/E_b = 10^{-4}$  or better*

*by Compton backscattering of laser light*

The idea to use Compton backscattering for beam energy determination has been refreshed in discussions with Amour Margaryan during a visit of Yerevan in autumn 2004

statement 'laser with low energy resp. large wavelength is preferred' was questioned (N. Muchnoi):

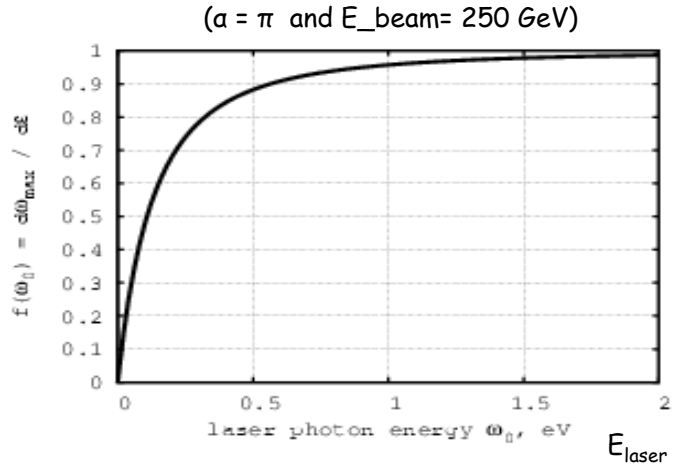
Max. scattered photon energy,  $E_\gamma(\max)$ , vs. laser energy  $E_{laser}$

$$E_\gamma^{\max} = E_{beam} \frac{\lambda}{1 + \lambda}$$

with

$$\lambda = \frac{4E_{laser}E_{beam}}{m^2} \sin^2 \frac{\alpha}{2}$$

derivative  $\frac{dE_\gamma^{\max}}{dE_{beam}}$  →

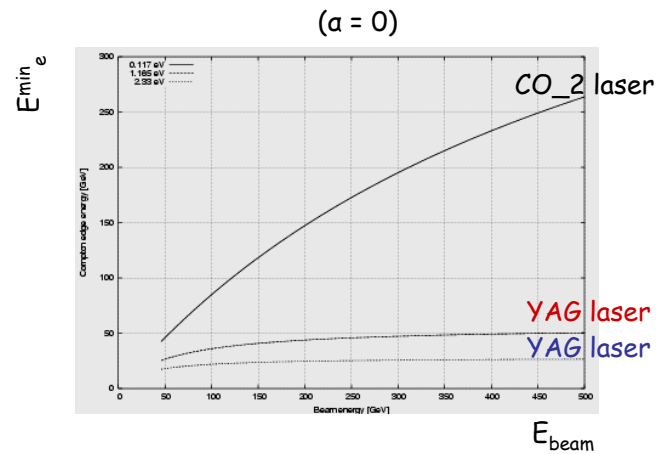


→ laser with shorter wavelength or larger energy → preferred

while Hannu Paukkunen (sommerstudent)

claimed the opposite for  $E_e(\min)$ !

$$E_e^{\min} = \frac{1}{1/E_{beam} + 2E_{laser}(1 + \cos \alpha)/m^2}$$



→ laser with larger wavelength or smaller energy → preferred

→ SOLUTION?



## Solution:

- Energy conservation:

$$E_{beam} + E_{laser} = E_e^{min} + E_\gamma^{max}$$



$$\frac{dE_e^{min}}{dE_{beam}} = 1 - \frac{dE_\gamma^{max}}{dE_{beam}}$$

and since  $dE_\gamma^{max}/dE_{beam}$  is rising from 0 to 1 with increasing  $E_{laser}$

the quantity  $(1 - dE_\gamma^{max}/dE_{beam})$  becomes smaller with increasing  $E_{laser}$

→ ergo, **both are right !**

Since we are primary interested on measuring the low-energy edge of the scattered electrons

→ a laser with low energy resp. large wavelength is preferred

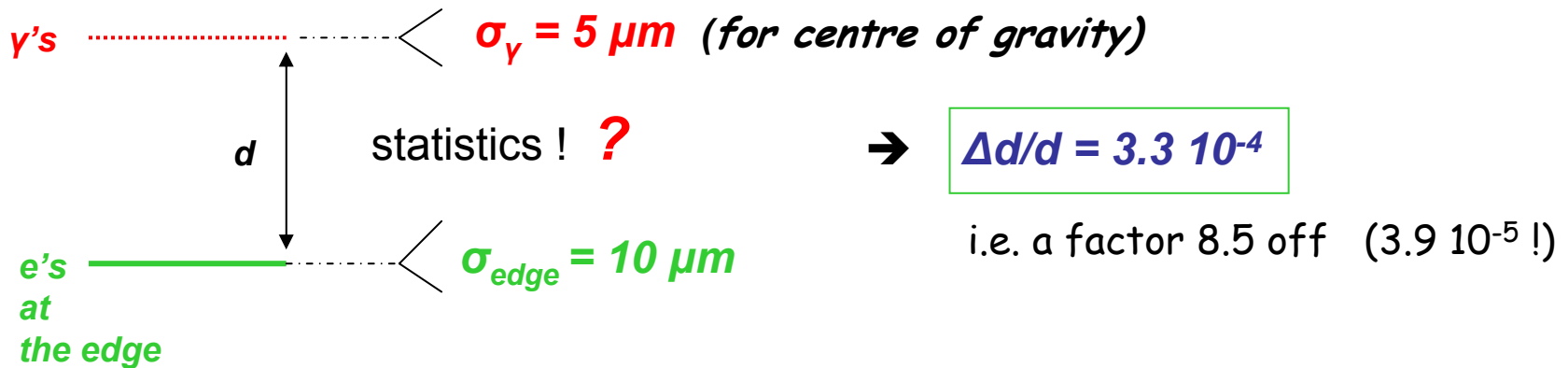
**CO<sub>2</sub> !**

(first guess !)

$$\frac{\Delta E_b}{E_b} = \sqrt{\left(\frac{\Delta B}{B}\right)^2 + \left(\frac{\Delta \theta}{\theta}\right)^2}$$

$$\frac{\Delta \theta}{\theta} = \sqrt{\left(\frac{\Delta L}{L}\right)^2 + \left(\frac{\Delta d}{d}\right)^2}$$

Assume



Possible way out:

$5 \mu\text{m} \rightarrow 3 \mu\text{m}$  and  $10 \mu\text{m} \rightarrow 5 \mu\text{m}$

$\rightarrow \Delta d/d = 1.7 \cdot 10^{-4}$

or increase  $L$  to 30 m

$\rightarrow \Delta d/d = 2.2 \cdot 10^{-4}$

or do both

$\rightarrow \Delta d/d = 1.1 \cdot 10^{-4}$

i.e. we are a factor 2.6 off

---

**With some optimism and further ideas/suggestions to improve the set-up  
it seems possible to achieve  $\Delta E_b/E_b = 5 \cdot 10^{-5}$**

## The task may be divided into three steps:

### Step No. 1

Fix the kinematics and understand the Compton scattering cross section w.r.t.

- the angle  $\alpha$ , the laser wavelength, the laser polarization for
  - a) unpolarized beam electrons at  $E_b = 250$  GeV (46 (Z pole), 500 GeV)
  - b) polarized beam electrons (longitudinal and transverse pol.)
- include the luminosity to estimate the rate of the Compton process  
in a detector

→ optimize the event rate

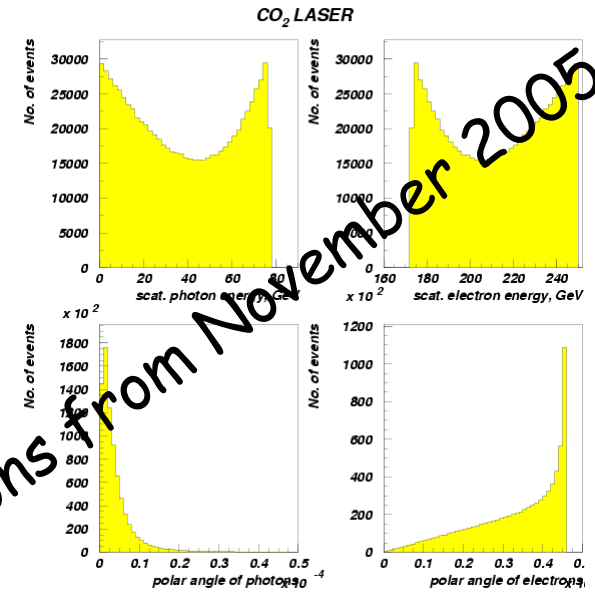
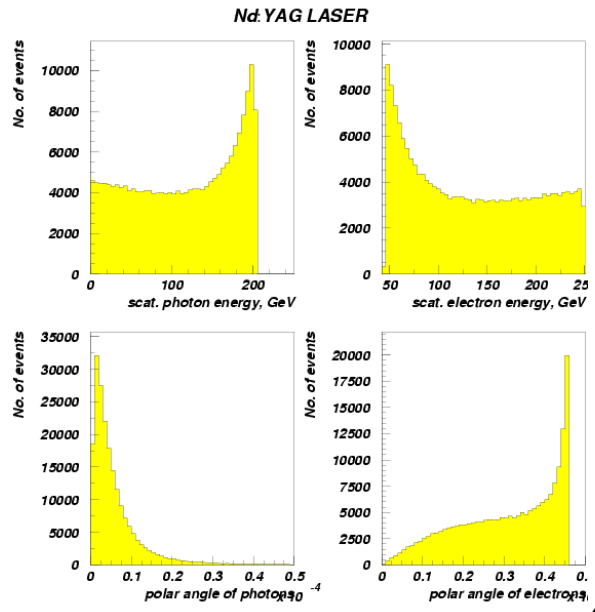
### Step No. 2

Based on the results from Step No.1, design an experimental layout for precise beam energy measurement, for each bunch crossing

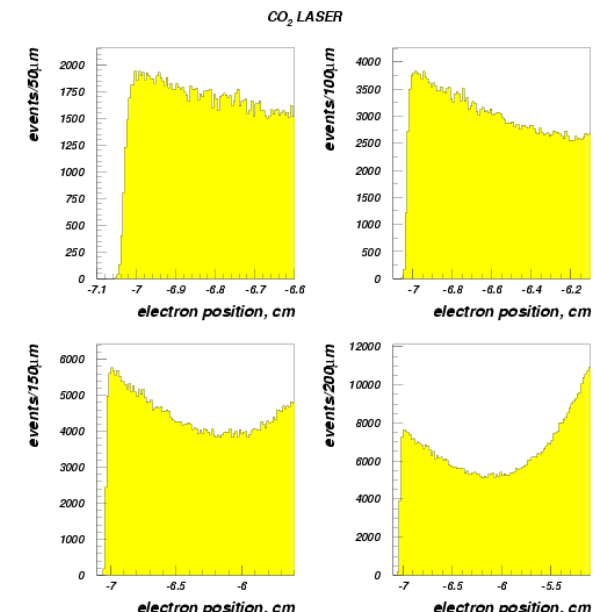
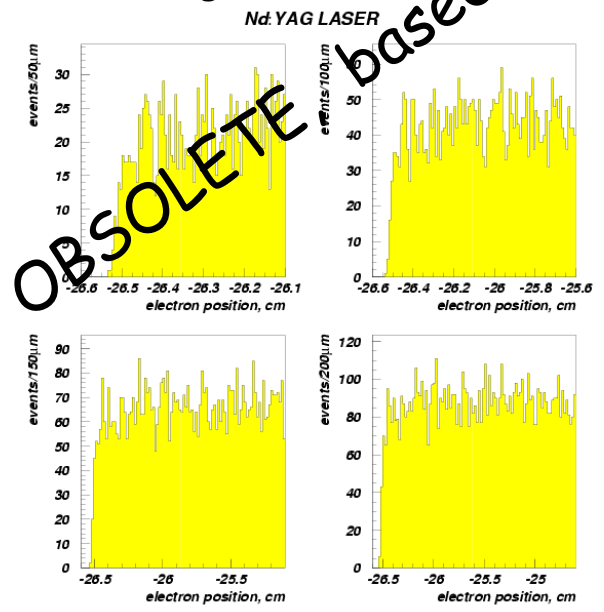
### Step No. 3

Try to have a first simulation of the experiment with GEANT

# Characteristics of scattered particles:



## Position of the edge electrons in the detector



OBSOLETE based on simulations from November 2005

Nikolai Muchnoi, May 2006,  $dE_{\gamma\text{max}}/dE_{\text{laser}}$  vs.  $E_{\text{laser}}$ , for  $E_{\text{beam}} = 250 \text{ GeV}$  and  $a = \pi$

